

<b>Notice of References Cited</b>	Application/Control No. 09/779,440	Applicant(s)/Patent Under Reexamination SHIOMI ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Collberg et al.; "Manufacturing Cheap, Resilient, and Stealthy Opaque Constructs"; January 1998; Annual Symposium on Principles of Programming Languages; pp. 184-196, <a href="http://citeseer.ist.psu.edu/collberg98manufacturing.html">http://citeseer.ist.psu.edu/collberg98manufacturing.html</a> .
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